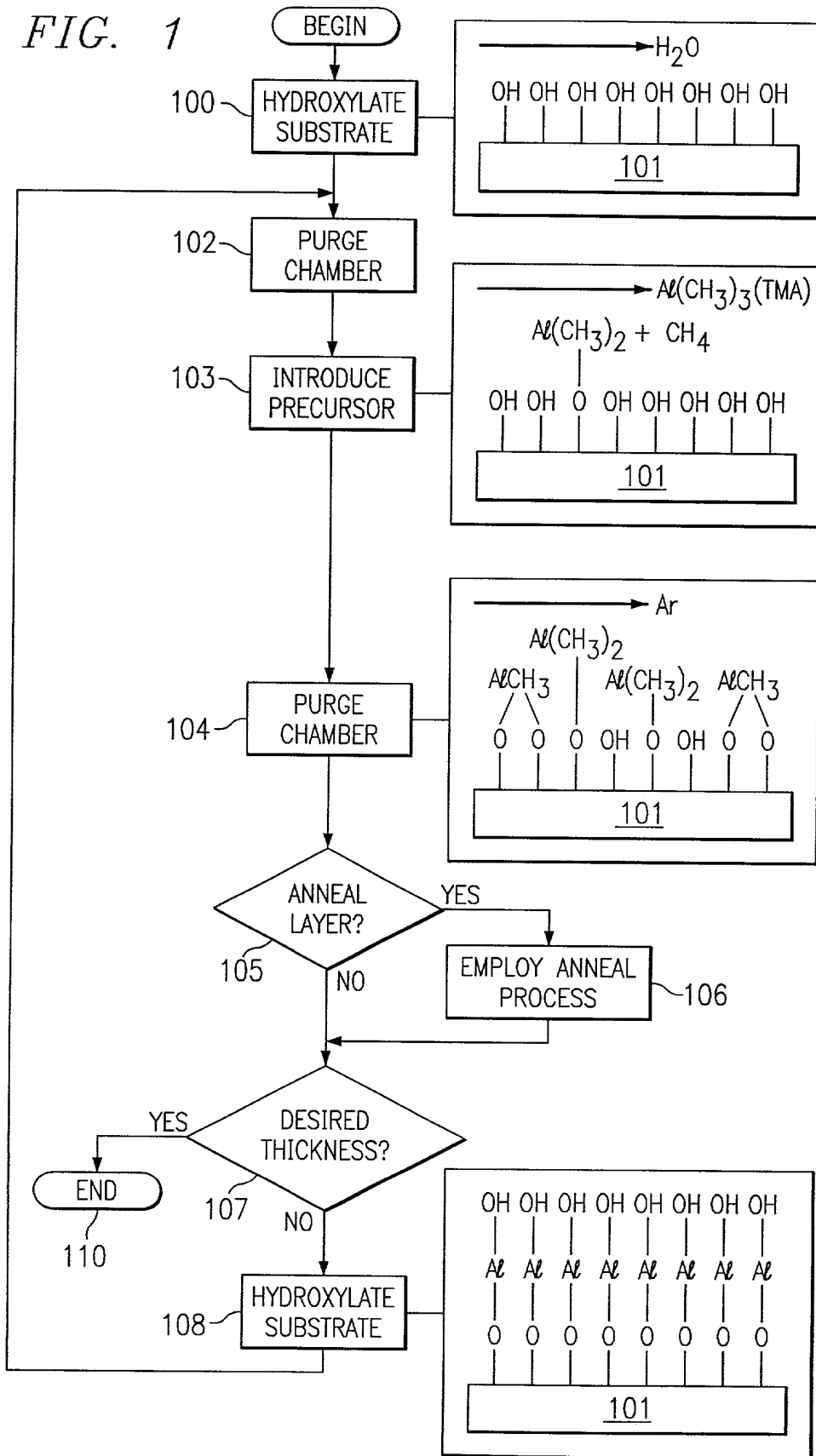


ATOMIC LAYER DEPOSITION FOR
FABRICATING THIN FILMS

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Express: EL740056656US Docket: 021208.0238

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FIG. 1



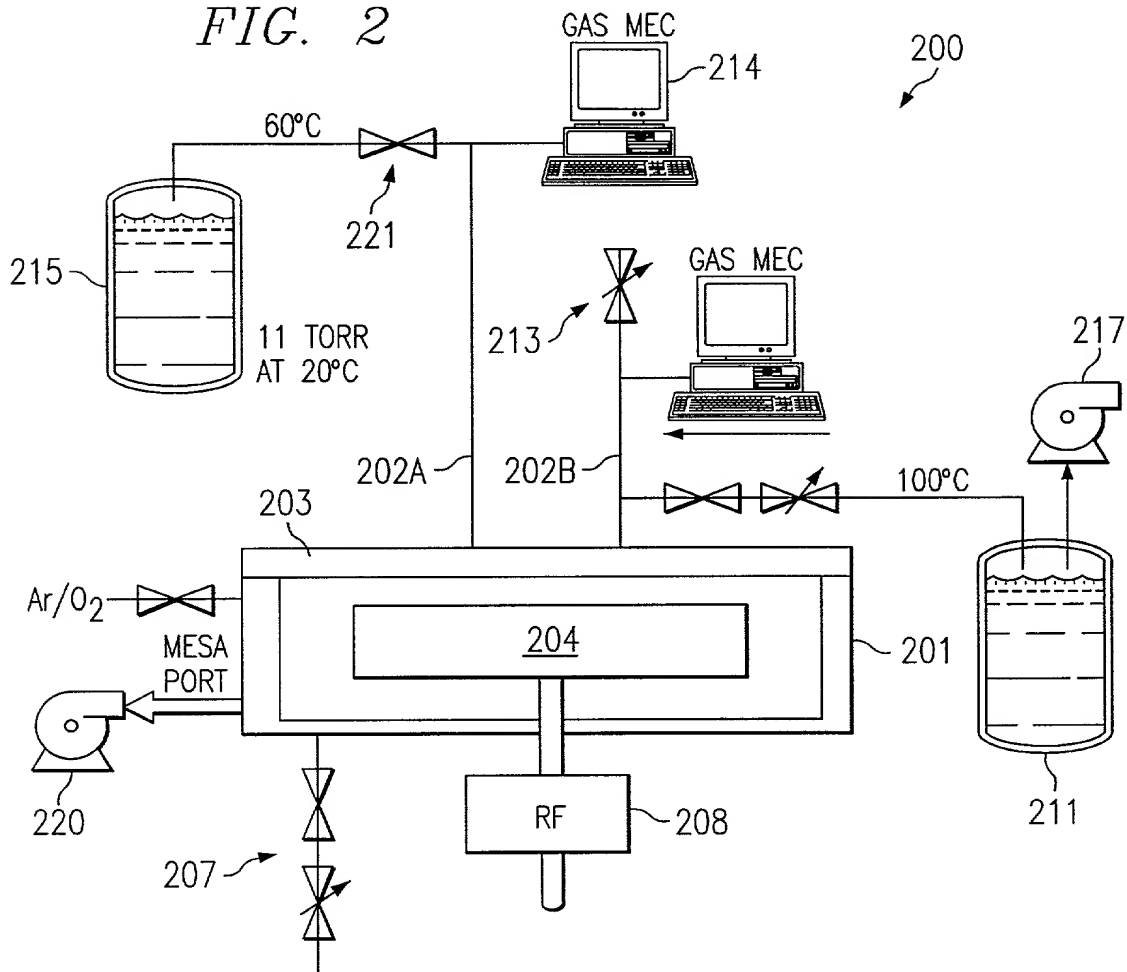
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FIG. 2



300

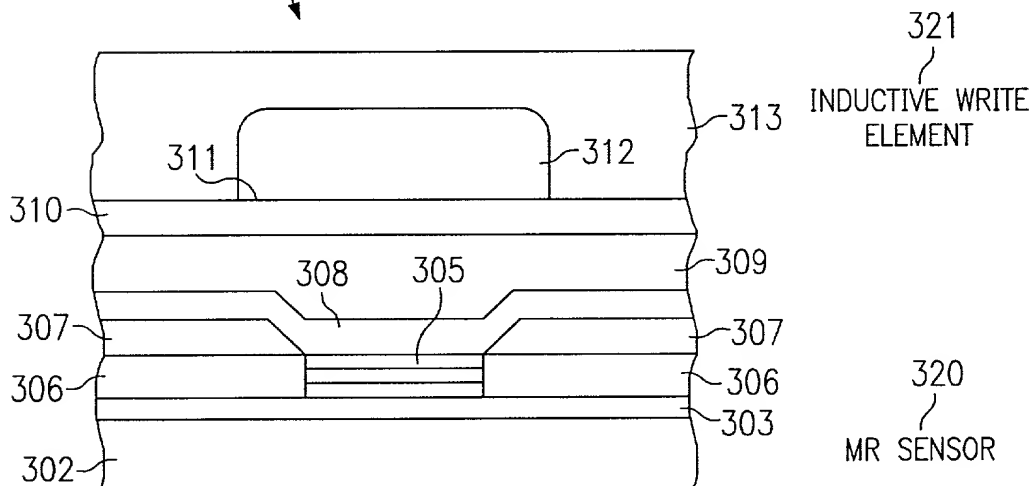


FIG. 3

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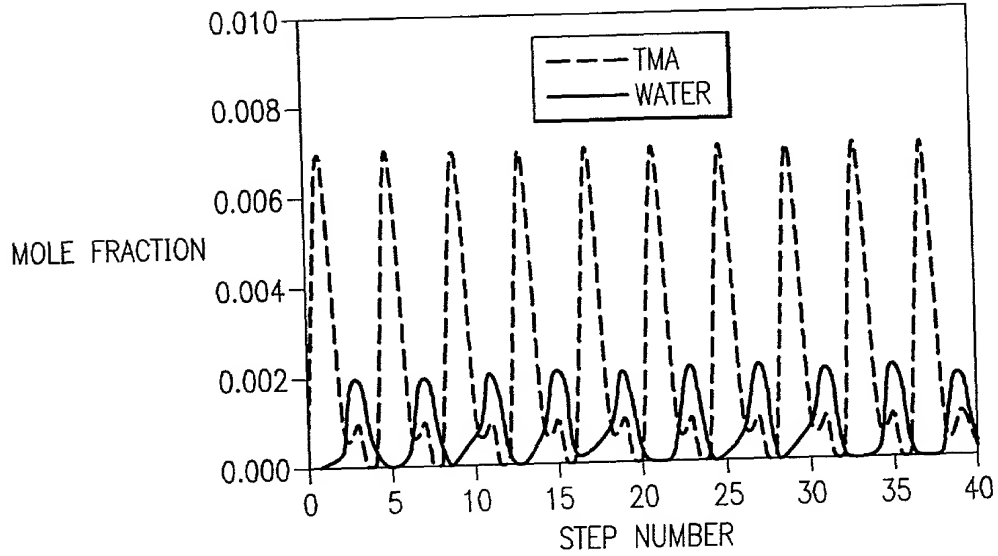


FIG. 4

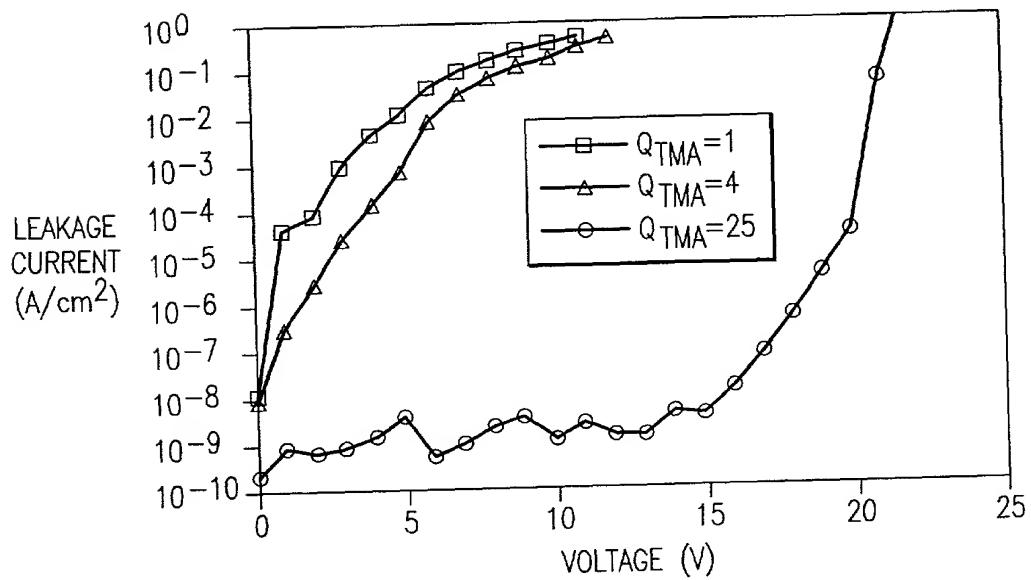


FIG. 5

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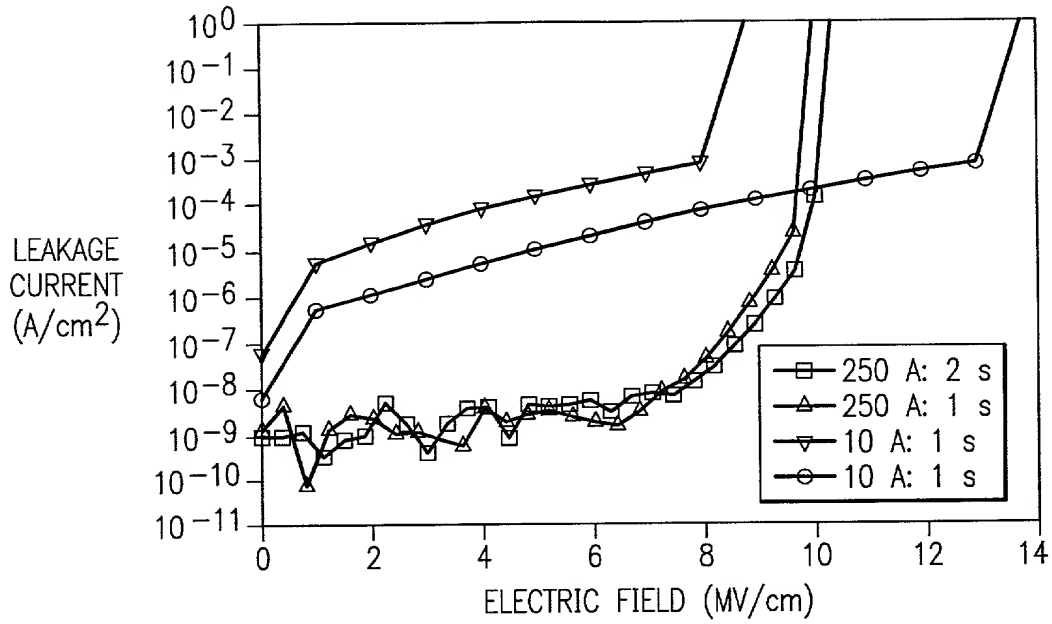


FIG. 6

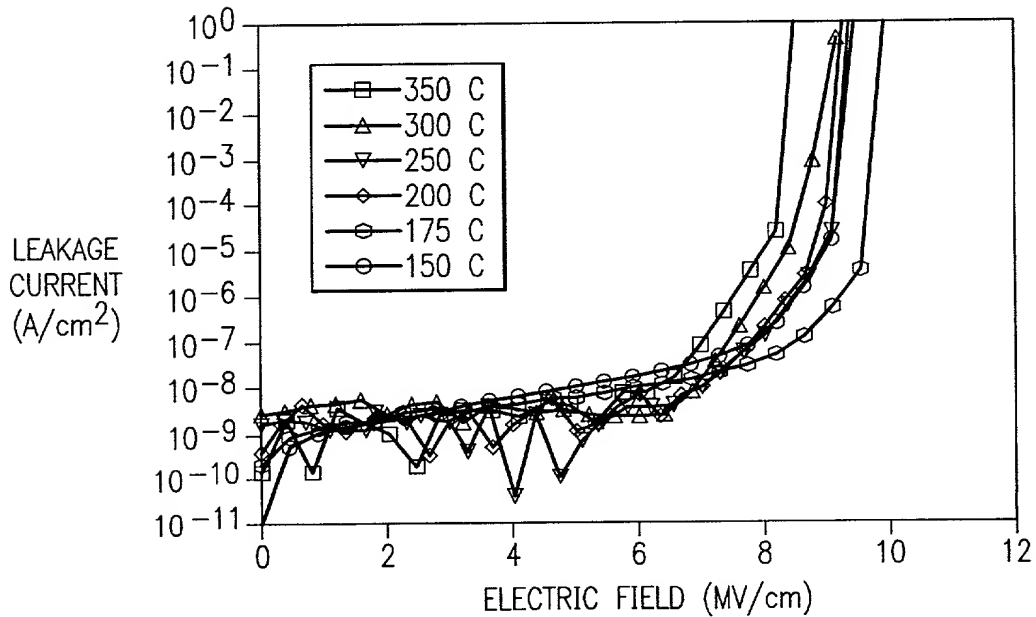


FIG. 7

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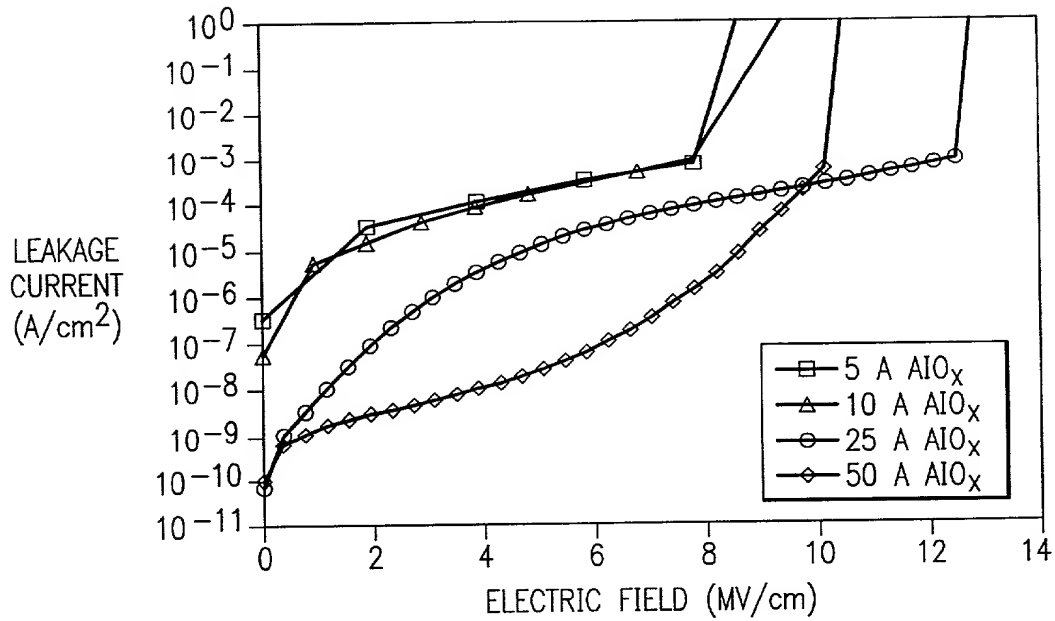


FIG. 8A

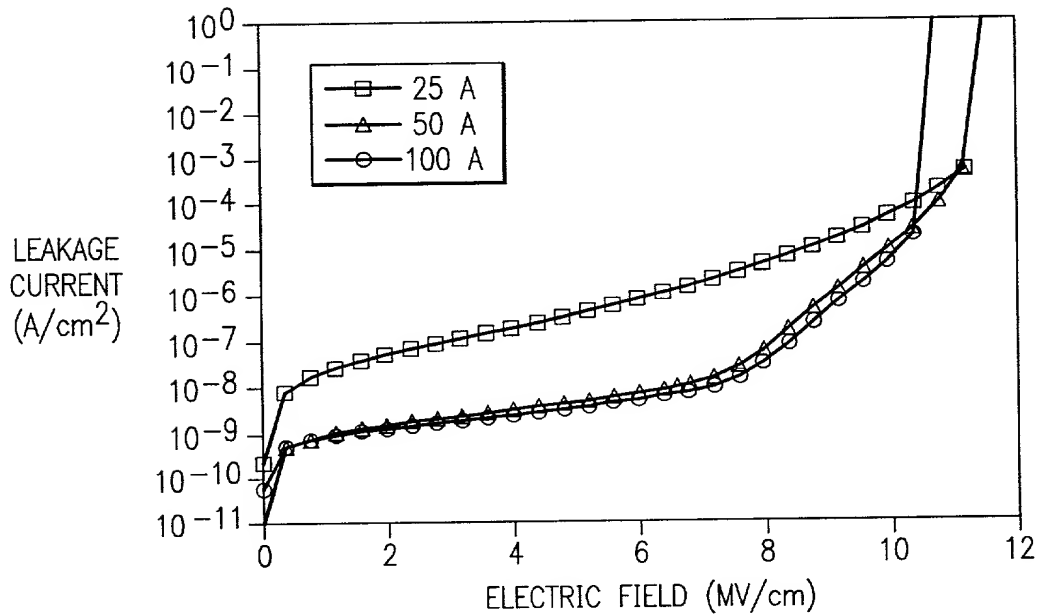


FIG. 8B

ATOMIC LAYER DEPOSITION FOR
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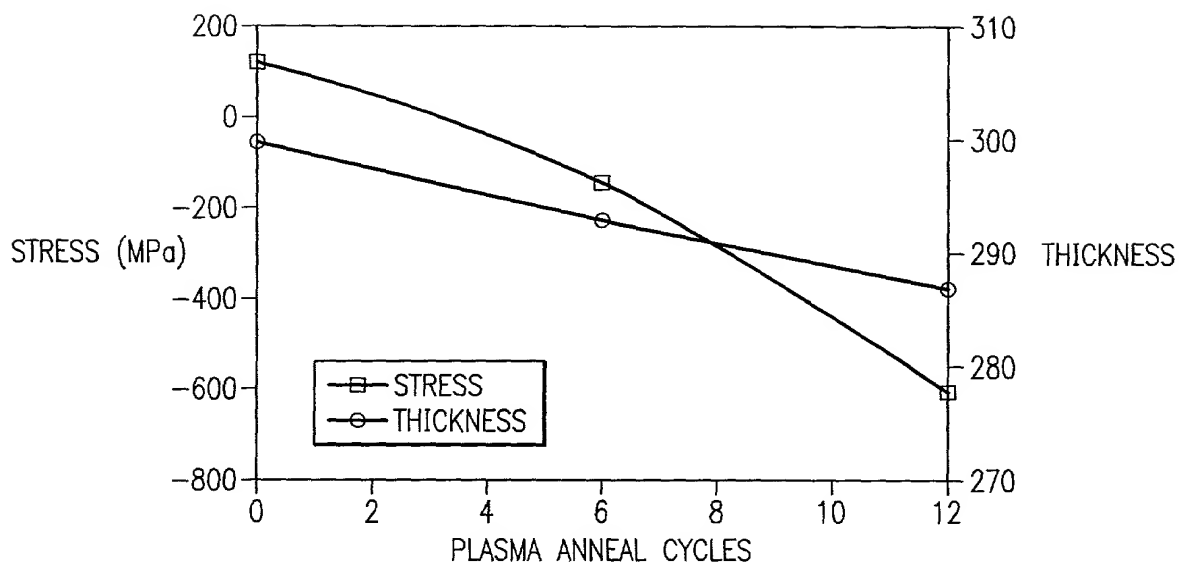


FIG. 9

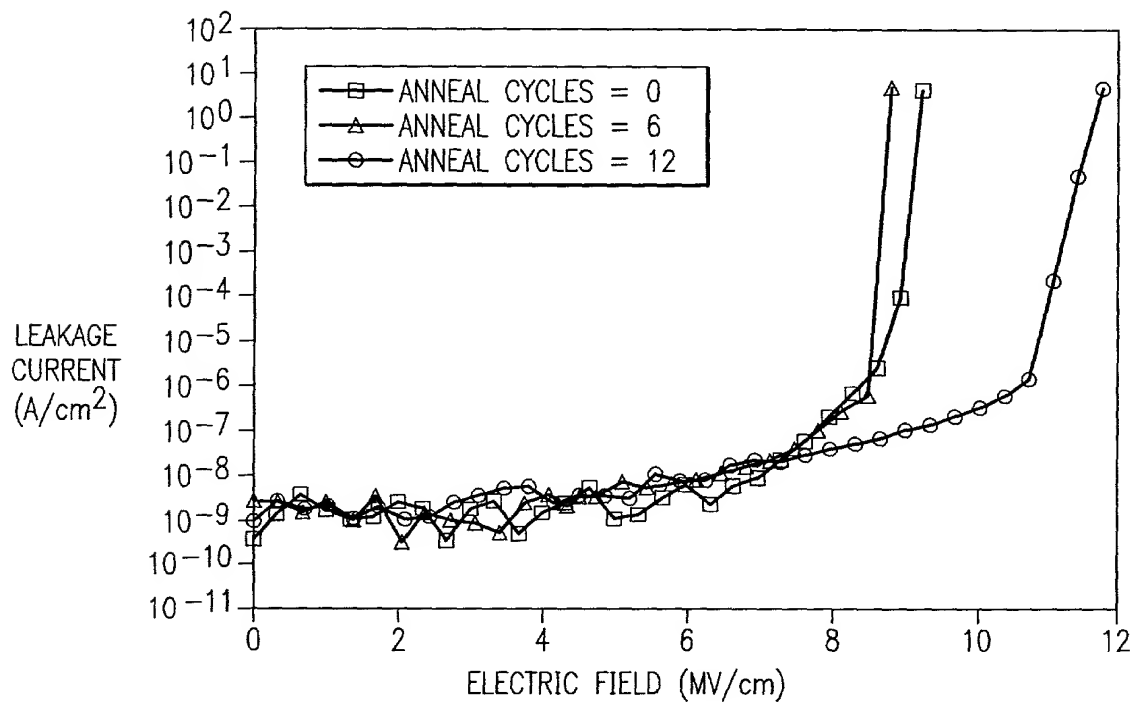


FIG. 10

TOMIC LAYER DEPOSITION FOR
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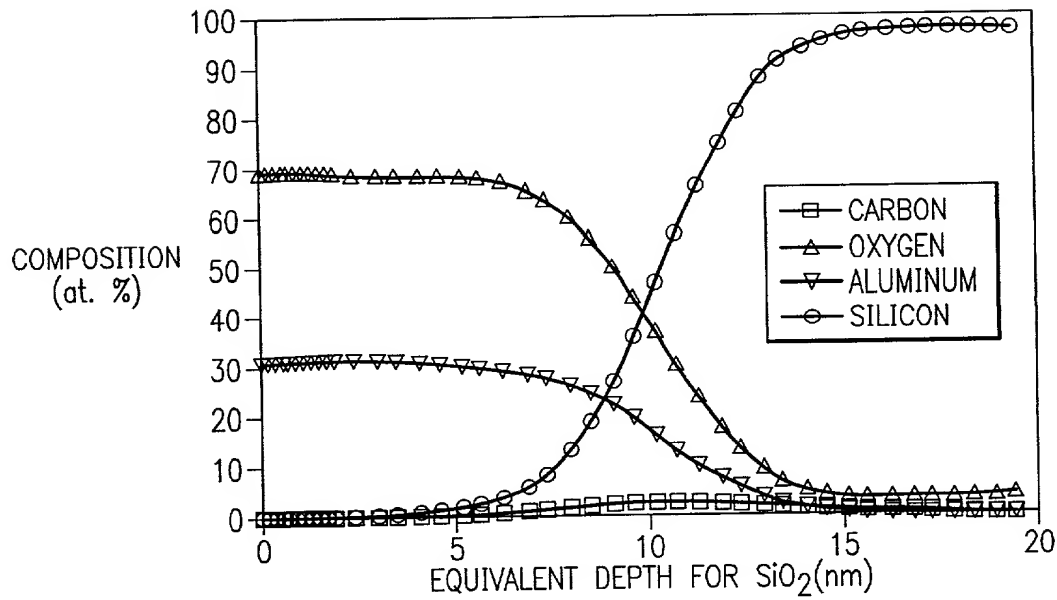


FIG. 11A

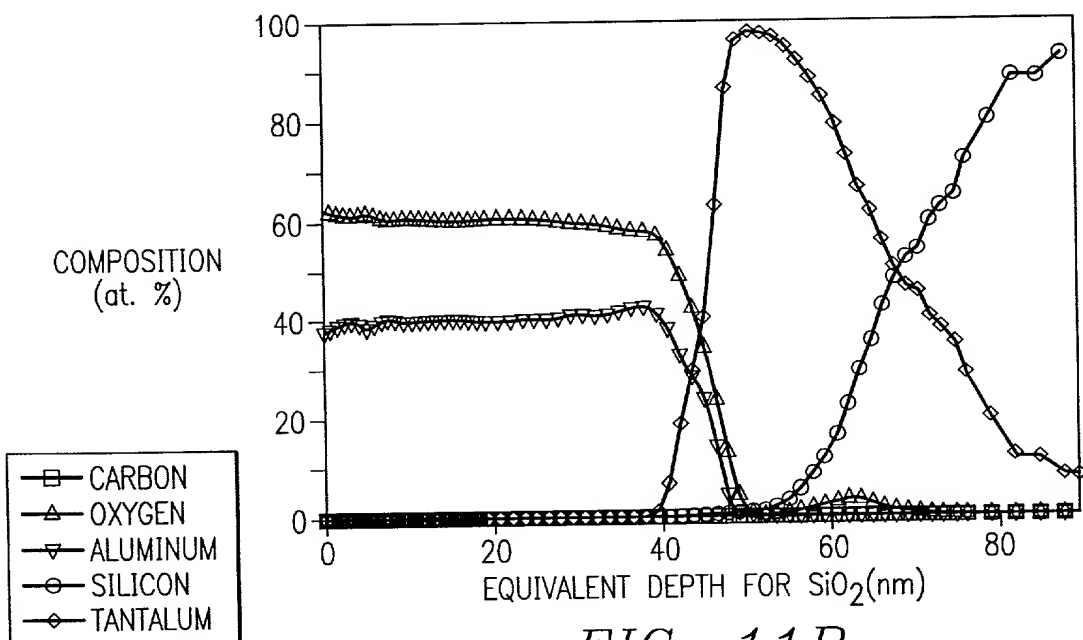


FIG. 11B